## **EUROPEAN PATENT OFFICE**

## **Patent Abstracts of Japan**

PUBLICATION NUMBER

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APPLICATION NUMBER

: 51042460

APPLICANT: HITACHI LTD;

INVENTOR: SATO HISASHI;

INT.CL. : H01J 37/14

TITLE

: MAGETIC FIELD TYPE ELECTRONIC LENS

ABSTRACT: PURPOSE: To designa magnetic path so that pole void becomes minus tolerance and to

absorb an alteration of the pole void portion by a non-magnetic material spacer.

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